

Technical Review on Beam Screen Heater Electronics

Quality assurance plan:

production, installation and commissioning

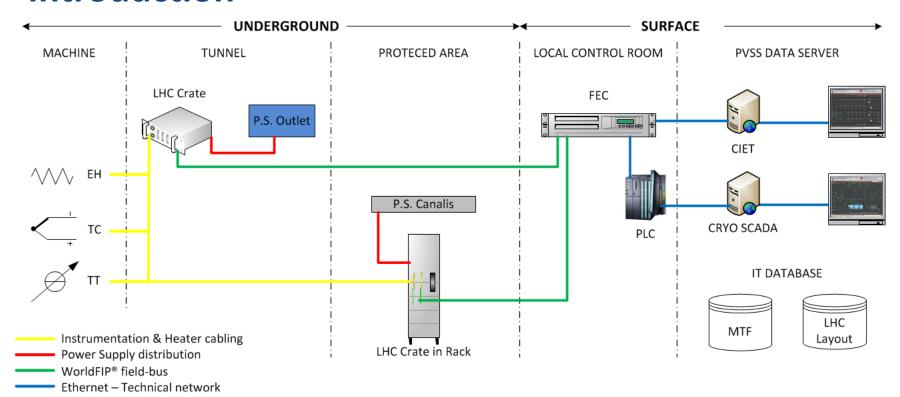
N.Vauthier
TE-CRG



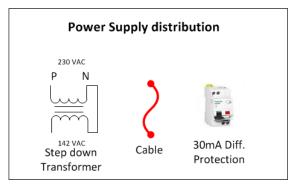
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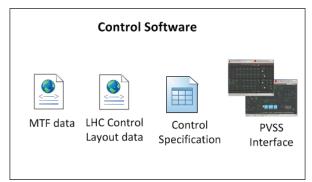
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Introduction



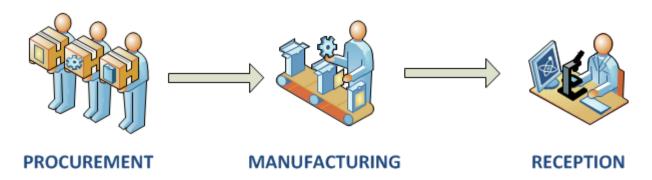








Due to volume (380 u.), time Schedule, and prototype reviews: NO PRESERIE



Procurement:

- TE-CRG is in charge to provide identified critical components (i.e.: FPGA, ADC, DAC, precision resistors)
- TE-MPE Design Office is in charge to select manufacturer, provide standard components, front panel and contract follow-up

Manufacturing requirements:

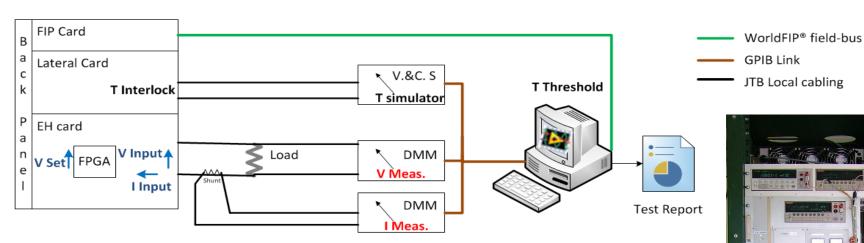
- QA: card has to be individually identified
- Automatic Optical Inspection mandatory before shipping
- Antistatic box for storage and shipping provide by TE-CRG
- Manufacturing report: AOI results vs equipment ID



Reception:

- Visual inspection
- CERN Part-ID labeling according to naming conventions for cryogenic instrumentation specification <u>LHC-QI-QA-0002 v.1.2</u>, EDMS 345385
- MTF registration in collaboration with GS-ASE
- Technical Verification with existing JUTRON Test Bench and based on <u>User Manual & Test Procedure</u>, EDMS 768747, prepared by E. Gousiou





Protocol:

Consolidation code to new EH type card

LabVIEW program: Voltage Set and Temperature Threshold

LHC operation	Beam	No Beam
Power [W]	0-25	25-500
Configuration Mode	DC	AC
Load [Ohm]	100	1000
Voltage Input range	0-60 V dc	230 VAC - PWM



Acceptance criteria:

Performance:

- DC/AC switch and operation modes
- V Input vs V Measured: ≤ 5%
- I Input vs I measured: ≤5%

Power OFF when:

- Enable/Disable mode from control panel
- Simulated Temperature > Interlock Temperature

Resource:

• Estimated time: 10 weeks, 1 FTE



POWER SUPPLY DISTRIBUTION

Cabling Specifications:

From LHC database layout

- 219 cables in LHC tunnel
- 78 cables in protected area

Where

- Maximal Nominal Current = 2.5A
- Main switch: compatible for 2x200VA toroidal transformer
- In protected area: 30mA differential protection
- End point is defined by crate location (DCUM)
- Start point has to be fixed by EN-EL from existing infrastructure taking into account that UPS connexion is NOT mandatory

Request fowarded to EN-EL-BT: mid-January 2013



POWER SUPPLY DISTRIBUTION

Step-down transformer:

- Industrial procurement, and specification has to be finalized by end-of march with following requirements
 - Toroidal type of 2x200VA
 - Mechanical housing with tunnel and rack installation
 - Compatible connectors for AC voltage
- Call for tender and order: 1rst april-2013
- Delivery foreseen: 1rst september 2013



CONTROL SOFTWARE

- Update MTF database:
 - Import equipment and test report from template
- Update LHC (controls) layout databases in collaboration with BE-CO
- Update control system in collaboration with EN-ICE
 - New communication specification to be implemented in FEC
 - Update CIET and CRYO interfaces

Start date: march 2013

End date: before mid-Feb 2014



Instrumentation:

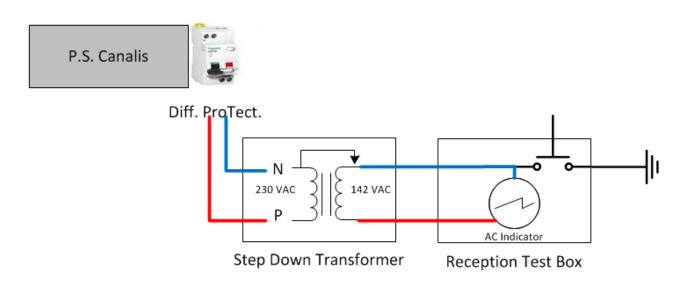
Etablish Thermocouple and heater validation on machine side with local apparatus:

- Physical values conform to LHC installation traveller
- Isolation vs ground
- Check TC polarity using external powering source
- repairs if applicable

This task should be partially done by IC train team

Power Supply Distribution:

Protocole reception when cable and step down transformer installation are done:



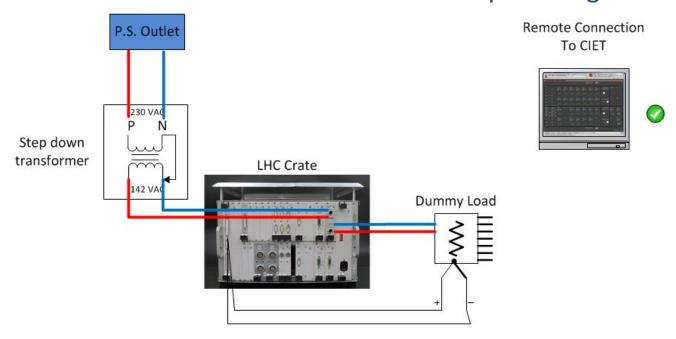
Performance:

- AC indicator conform to 142VAC
- Differential protection operational



Electronic card installation and validation protocol:

- Replace previous electronic card
- Using an external dummy load
- Remote connection to set and control heater powering

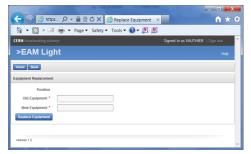


 Plug heater connector to the machine only if previous step is succesfull



Traceability and Quality Assurance:

Validation of card replacement to update MTF with <u>EAM-Light</u> apex



Handling retired equipment according to RP rules with <u>TREC</u> apex



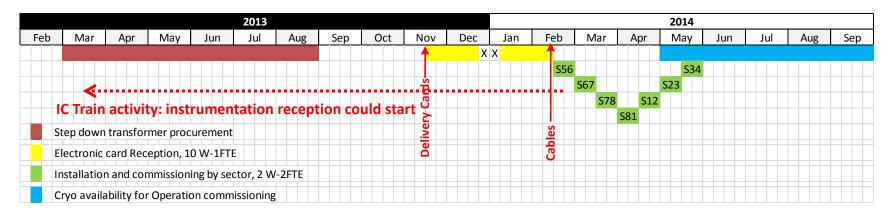
KDC300i, 2D Terminal BlueTooth



Resource:

- Global estimation for Instrumentation, Power Supply distribution,
 Electronic card and QA procedure is: 2 Weeks /2 FTE by sector
- Operating every single heater from PVSS in collaboration with Cryo operation team: 2 Days by sector

Schedule:





CONCLUSION

- Manufacturing, installation and commissioning phases are now identified: QA procedure, Technical specification and resource
- Project compatible with Cryo commissioning if no significant delay in:
 - Critical component procurement
 - Prototype validation
 - Power supply distribution
- Instrumentation validation starts already in 2013, therefore Installation and commissioning could be reduced by 1 month. This additional month would be allocated to prototyping
- Still request EN-MEF validation: LS1 official schedule

Many thanks for your attention.



